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Reply to Office Action mailed November 2, 2006

DEC 29 2006

PATENT
790001-2042IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Naofumi Nakamura et al.
Serial No. : 10/752,642
For : SEMICONDUCTOR DEVICE AND METHOD OF
FABRICATING THE SAME
Filing Date : January 7, 2004
Examiner : Jesse A. Fenty
Group Art Unit : 2815
Confirmation No. : 4109

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Bernadette Vassallo

Signature

December 29, 2006

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745 Fifth Avenue
New York, NY 10151

RESPONSE**MAIL STOP AMENDMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This response is submitted in reply to the Final Office Action in the above-captioned application mailed on November 2, 2006, having a three-month statutory period for response set to expire on February 2, 2007, Applicants respond as follows.